

Notice of References Cited	Application/Control No. 10/593,337	Applicant(s)/Patent Under Reexamination HEINRICH ET AL.	
	Examiner Shih-Chao Chen	Art Unit 2821	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,903,239	05-1999	Takahashi et al.	343/700MS
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
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	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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*	N	JP 09252217 A	09-1997	Japan	Honma et al.	H01Q 23/00
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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